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Application/Control No.	Applicant(s)/Patent under Reexamination	
09/932,866	CHAUVEL ET AL.	
Examiner	Art Unit	
Hong C. Kim	2185	

SEARCHED					
Class	Subclass	Date	Examiner		
upda	Se	2/8/06	14		

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	

(INCLUDING SEARCI	H STRATEGY)
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